



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 3, 2026	
IGI Report Number	LG814611885
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	12.04 X 8.67 X 5.79 MM

GRADING RESULTS

Carat Weight	4.88 CARATS
Color Grade	F
Clarity Grade	VS 1

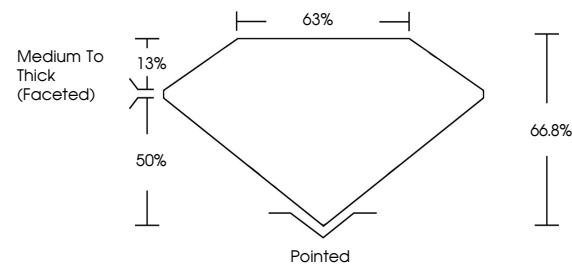
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG814611885

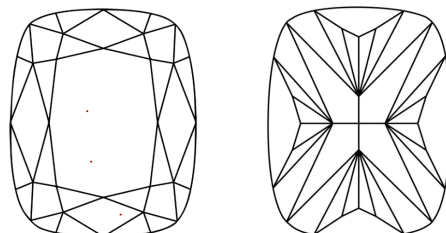
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG814611885
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

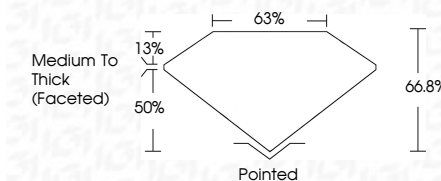
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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July 3, 2026	GI Report No. LG814611885	4.88 CARATS	F
CU SHIMON MODIFIED BRILLIANT			VS 1
			66.8%
			63%
			Medium to Thick (Faceted)
			Pointed
			EXCELLENT
			EXCELLENT
			NONE
			1881 LG814611885

Comments: This is a Very Good Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA